

GEN0009-US



*IPD*  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

TZU-EN HO ET AL.

Serial No.: 10/726,500

Filed: December 4, 2003

For: METHOD FOR MANUFACTURING  
GATE STRUCTURE FOR USE IN  
SEMICONDUCTOR DEVICE

Art Unit: 2813

Examiner: MITCHELL, JAMES M.

**RESPONSE TO ELECTION OF SPECIES REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on June 2, 2005, Applicants hereby provisionally elect, with traverse, species 1-4 and 9-12 for initial examination in the present application.

Claims 1-4 and 9-12 read on the elected species and are generic to all of species outlined in the Office Action.

However, applicants respectfully traverse the election requirement since all of species are sufficiently related that a thorough and complete search for species 1-4 and 9-12 would necessarily encompass a thorough and complete search for the non-elected species. Accordingly, it is respectfully requested that the election requirement be withdrawn and that all species claimed herein be examined.

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Attorney's Docket No.: GEN0009-US  
Page 2

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Tel: 703/770-7900

Date: June 16, 2005

Respectfully submitted,

TZU-EN HO ET AL.

By:   
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LDE/ggb

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